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Serial No.: 10/067,425

Conf. No.: 7853

Filing Date: 02/04/2002

Art Unit: 2829

Applicant: Van Veen et al.

Examiner: GEYER, S

Title: METHOD OF MANUFACTURING
A SEMICONDUCTOR DEVICE AND A
SEMICONDUCTOR DEVICE OBTAINED
BY MEANS OF SAID METHOD

Docket No.: NL0100690

~~OFFICIAL~~

COMMISSIONER FOR PATENTS

DESTINATION FACSIMILE NUMBER: 703-872-9306

Transmitted herewith is:

Amendment in 14 pages
Replacement sheet 1 page

in the above identified application.


- ☒ No additional fee is required.
- ☒ The Commissioner is hereby authorized to charge and credit Deposit Account No. 500999 as described below.
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required.


Michael F. Hoffman, Reg. No. 40, 019

DATE: June 1, 2004

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on the date shown below.

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In re Application of: Van Veen et al.

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Title: METHOD OF MANUFACTURING A
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BY MEANS OF SAID METHOD

EXAMINER: GEYER, S

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

I. INTRODUCTORY COMMENTS:

In response to the Office Action of March 1, 2004, please amend the above-referenced patent application as follows:

Serial No.: 10/067,425

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